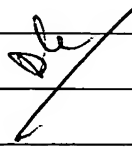
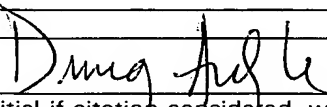


FORM PTO-1449		Docket Number (Optional) 072219-0278259 (P05108)	Application No. New
INFORMATION DISCLOSURE CITATION IN AN APPLICATION Express Mail Number <u>6115 407355245</u> (Use several sheets if necessary)		Applicant(s) Heikyung Min et al.	
		Filing Date Herewith	Group Art Unit Unknown

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U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER					
	DATE					
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	CLASS					
	SUBCLASS					
	FILING DATE IF APPROPRIATE					

FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER					
	DATE					
	COUNTRY					
	CLASS					
	SUBCLASS					
	Translation					
	Yes					
	No					

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
	James Dunkley et al., "Hot Electron Induced Hydrogen Compensation of Boron Doped Silicon Resulting From Emitter-Base Breakdown", IEEE, 1992, pps. 31.4.1 - 31.4.3.
	M. Soltani-Farshi et al., "Thermal Behaviour of Implanted Nitrogen and Accumulated Hydrogen in Titanium", 1998, Mat. Res. Symp. Proc. Vol. 504, Materials Research Society, pps. 231-237.
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EXAMINER	DATE CONSIDERED
	7/02
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	